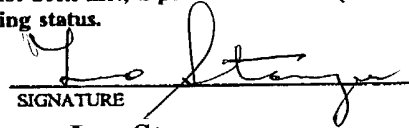


Express Mail

EL545270749US

10090944-032602  
309 Rec'd PCT/PTO 11 DEC 2001

FORM PTO-1390 (REV. 9-2001)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTORNEY'S DOCKET NUMBER <b>HOLTR-400</b>	
TRANSMITTAL LETTER TO THE UNITED STATES DESIGNATED/ELECTED OFFICE (DO/EO/US) CONCERNING A FILING UNDER 35 U.S.C. 371				U.S. APPLICATION NO. (If known, use 37 CFR 1.5) <b>10/009944</b>	
INTERNATIONAL APPLICATION NO. <b>PCT/IB00/00794</b>		INTERNATIONAL FILING DATE <b>13 JUNE 2000</b>		PRIORITY DATE CLAIMED <b>11 JUNE 1999</b>	
TITLE OF INVENTION <b>Method and Apparatus For Recording A Hologram From A Mask Pattern By The Use Of Total Internal Reflection Holography and Hologram Manufactured by the Method</b>					
APPLICANT(S) FOR DO/EO/US <b>Han, Woo-Sung; Clube, Francis; Carnal, Oliver</b>					
Applicant herewith submits to the United States Designated/Elected Office (DO/EO/US) the following items and other information:					
<p>1. <input checked="" type="checkbox"/> This is a <b>FIRST</b> submission of items concerning a filing under 35 U.S.C. 371.</p> <p>2. <input type="checkbox"/> This is a <b>SECOND</b> or <b>SUBSEQUENT</b> submission of items concerning a filing under 35 U.S.C. 371.</p> <p>3. <input type="checkbox"/> This is an express request to begin national examination procedures (35 U.S.C. 371(f)). The submission must include items (5), (6), (9) and (21) indicated below.</p> <p>4. <input checked="" type="checkbox"/> The US has been elected by the expiration of 19 months from the priority date (Article 31).</p> <p>5. <input type="checkbox"/> A copy of the International Application as filed (35 U.S.C. 371(c)(2))</p> <p>a. <input checked="" type="checkbox"/> is attached hereto (required only if not communicated by the International Bureau).</p> <p>b. <input type="checkbox"/> has been communicated by the International Bureau.</p> <p>c. <input type="checkbox"/> is not required, as the application was filed in the United States Receiving Office (RO/US).</p> <p>6. <input type="checkbox"/> An English language translation of the International Application as filed (35 U.S.C. 371(c)(2)).</p> <p>a. <input type="checkbox"/> is attached hereto.</p> <p>b. <input type="checkbox"/> has been previously submitted under 35 U.S.C. 154(d)(4).</p> <p>7. <input type="checkbox"/> Amendments to the claims of the International Application under PCT Article 19 (35 U.S.C. 371(c)(3))</p> <p>a. <input type="checkbox"/> are attached hereto (required only if not communicated by the International Bureau).</p> <p>b. <input type="checkbox"/> have been communicated by the International Bureau.</p> <p>c. <input type="checkbox"/> have not been made; however, the time limit for making such amendments has NOT expired.</p> <p>d. <input type="checkbox"/> have not been made and will not be made.</p> <p>8. <input type="checkbox"/> An English language translation of the amendments to the claims under PCT Article 19 (35 U.S.C. 371 (c)(3)).</p> <p>9. <input type="checkbox"/> An oath or declaration of the inventor(s) (35 U.S.C. 371(c)(4)).</p> <p>10. <input type="checkbox"/> An English language translation of the annexes of the International Preliminary Examination Report under PCT Article 36 (35 U.S.C. 371(c)(5)).</p> <p>Items 11 to 20 below concern document(s) or information included:</p> <p>11. <input type="checkbox"/> An Information Disclosure Statement under 37 CFR 1.97 and 1.98.</p> <p>12. <input type="checkbox"/> An assignment document for recording. A separate cover sheet in compliance with 37 CFR 3.28 and 3.31 is included.</p> <p>13. <input checked="" type="checkbox"/> A <b>FIRST</b> preliminary amendment.</p> <p>14. <input type="checkbox"/> A <b>SECOND</b> or <b>SUBSEQUENT</b> preliminary amendment.</p> <p>15. <input type="checkbox"/> A substitute specification.</p> <p>16. <input type="checkbox"/> A change of power of attorney and/or address letter.</p> <p>17. <input type="checkbox"/> A computer-readable form of the sequence listing in accordance with PCT Rule 13ter.2 and 35 U.S.C. 1.821 - 1.825.</p> <p>18. <input type="checkbox"/> A second copy of the published international application under 35 U.S.C. 154(d)(4).</p> <p>19. <input type="checkbox"/> A second copy of the English language translation of the international application under 35 U.S.C. 154(d)(4).</p> <p>20. <input type="checkbox"/> Other items or information:</p>					

U.S. APPLICATION NO. <b>10/009944</b>		INTERNATIONAL APPLICATION NO. <b>PCT/IB00/00794</b>		ATTORNEY'S DOCKET NUMBER <b>HOLTR-400</b>	
21. <input checked="" type="checkbox"/> The following fees are submitted: <b>BASIC NATIONAL FEE (37 CFR 1.492 (a) (1) - (5)):</b> Neither international preliminary examination fee (37 CFR 1.482) nor international search fee (37 CFR 1.445(a)(2)) paid to USPTO and International Search Report not prepared by the EPO or JPO. .... <b>\$1040.00</b> International preliminary examination fee (37 CFR 1.482) not paid to USPTO but International Search Report prepared by the EPO or JPO ..... <b>\$890.00</b> International preliminary examination fee (37 CFR 1.482) not paid to USPTO but international search fee (37 CFR 1.445(a)(2)) paid to USPTO ..... <b>\$740.00</b> International preliminary examination fee (37 CFR 1.482) paid to USPTO but all claims did not satisfy provisions of PCT Article 33(1)-(4) ..... <b>\$710.00</b> International preliminary examination fee (37 CFR 1.482) paid to USPTO and all claims satisfied provisions of PCT Article 33(1)-(4) ..... <b>\$100.00</b> <b>ENTER APPROPRIATE BASIC FEE AMOUNT =</b>				<b>CALCULATIONS PTO USE ONLY</b>	
				<b>\$ 1040.00</b>	
Surcharge of \$130.00 for furnishing the oath or declaration later than <input type="checkbox"/> 20 <input type="checkbox"/> 30 months from the earliest claimed priority date (37 CFR 1.492(e)).				<b>\$</b>	
CLAIMS	NUMBER FILED	NUMBER EXTRA	RATE	\$	
Total claims	- 20 =		x \$18.00	\$	
Independent claims	- 3 =		x \$84.00	\$	
MULTIPLE DEPENDENT CLAIM(S) (if applicable)				+ \$280.00	
<b>TOTAL OF ABOVE CALCULATIONS =</b>				<b>\$ 1040.00</b>	
<input checked="" type="checkbox"/> Applicant claims small entity status. See 37 CFR 1.27. The fees indicated above are reduced by 1/2.				+ \$	
<b>SUBTOTAL =</b>				<b>\$ 520.00</b>	
Processing fee of \$130.00 for furnishing the English translation later than <input type="checkbox"/> 20 <input type="checkbox"/> 30 months from the earliest claimed priority date (37 CFR 1.492(f)).				<b>\$</b>	
<b>TOTAL NATIONAL FEE =</b>				<b>\$ 520.00</b>	
Fee for recording the enclosed assignment (37 CFR 1.21(h)). The assignment must be accompanied by an appropriate cover sheet (37 CFR 3.28, 3.31). \$40.00 per property +				<b>\$</b>	
<b>TOTAL FEES ENCLOSED =</b>				<b>\$ 520.00</b>	
				Amount to be refunded: \$	
				charged: \$	
a. <input checked="" type="checkbox"/> A check in the amount of \$ <u>520.00</u> to cover the above fees is enclosed.					
b. <input type="checkbox"/> Please charge my Deposit Account No. _____ in the amount of \$ _____ to cover the above fees. A duplicate copy of this sheet is enclosed.					
c. <input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. <u>19-4124</u> . A duplicate copy of this sheet is enclosed.					
d. <input type="checkbox"/> Fees are to be charged to a credit card. <b>WARNING:</b> Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.					
<b>NOTE:</b> Where an appropriate time limit under 37 CFR 1.494 or 1.495 has not been met, a petition to revive (37 CFR 1.137 (a) or (b)) must be filed and granted to restore the application to pending status.					
SEND ALL CORRESPONDENCE TO:					
<b>Leo Stanger</b> <b>P O Box 1455</b> <b>382 Springfield Ave</b> <b>Summit NJ 07901</b>			SIGNATURE  <b>Leo Stanger</b> NAME <b>19,188</b> REGISTRATION NUMBER		

**Docket HOLT-400**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor : **Woo-Sung Han et al**  
Serial No. : **10/009,944**  
I. A. Filing Date : **June 13, 3000**  
Priority Date : **June 11, 1999**  
I. A. Number : **PCT/IB00/00794**  
For : **Method And Apparatus For Recording A Hologram From A  
Mask Pattern By The Use Of Total Internal Reflection  
Holography And Hologram Manufactured By The Method**

Hon. Commissioner of Patents & Trademarks  
Washington D. C. 20231

Sir:

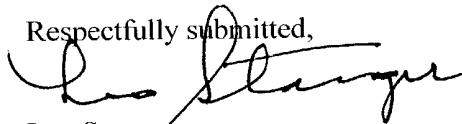
## PRELIMINARY AMENDMENT

Prior to an Office Action in this application, please amend this application as follows:

Cancel claims 7, 9, 10, 12, 15, 16, 19, 21, 22, 23, 24, 27, 28, 31, 33, 34, 36, 38, and 39.

Copies of the claims as amended and showing amendments are attached.

Respectfully submitted,



Leo Stanger  
Registration No. 19,188

Stanger & Dreyfus P.C.  
382 Springfield Avenue  
Summit, NJ 07901  
(908) 277-8588

Version with Markings to Show Changes MadeClaims:

1. Method of forming a hologram from a information containing mask, comprising the following steps:
  - 5 - arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
  - arranging a information containing mask in a spaced relationship and parallel to the substrate;
  - 10 - generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
  - - directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled
  - 15 - directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;
  - 20 further including the steps of
  - employing a photoresist as the holographic recording medium; and
  - arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are
  - 25 substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.
- 30 2. Method according to claim 1, characterized in that substantially only the transmission hologram is recorded in the holographic recording layer.

3. Method according to claim 1 , characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

5

4. Method according to claim 1 , characterized in that the plane of polarisation of the object beam is at  $45^\circ$  to the plane of incidence of the reference beam at the holographic recording layer.

10

5. Method according to claim 1 , characterized in that the photoresist material is selected such that its thickness (d) and absorption (a) meet the condition  $a \cdot d < 1$ .

15

6. Method according to claim 1 , characterized in that the photoresist is selected such that its contrast described by its gamma-value satisfies the condition  $\gamma < 3$ .

20 ~~7. Method according to claim 1 , characterized in that the photoresist is selected such that its resolution described by the smallest period of grating that can be optically recorded in the material is with a modulation depth  $(d_{\max} - d_{\min}) / (d_{\max} + d_{\min}) > 25\%$  satisfies the condition~~  
25  ~~$\Lambda < 200 \text{ nm}$ .~~

8. Method according to claim 1 , characterized in that laser light of a wavelength below 300nm, and preferably of a wavelength between 150 and 260 nm for  
30 recording the hologram is used.

- ~~9. Method according to claim 1, characterized in the polarisation angles are selected according to the refractive index of the photoresist.~~
- 5 ~~10. Method according to claim 1, characterized in that a combination of polarisation angles of between 37 to 44°, preferably 39° for the reference beam and -43 to -47°, preferably -45° for the object beam with respect to the plane of incidence are applied.~~
- 10 11. Method according to claim 1, characterized in that the intensity of the reference beam exceeds that of the object beam.
- 15 ~~12. Method according to claim 1, characterized in that the intensity of the reference beam exceeds that of the object beam by a factor 2, and preferably is 4 : 1.~~
- 20 13. Method according to claim 1, characterized in that the intensity ratio of the object and reference beams is between 3:1 and 5:1, and preferably about 4:1.
- 25 14. Method according to claim 1 to 13, characterized in that the thickness of the photoresist layer is less than 500 nm, preferably between 100 and 300 nm and most preferably between 200 and 300 nm.
- 30 ~~15. Method according to claim 1 to 14, characterized in that the image recorded in the photoresist as surface relief hologram is transferred into the substrate material by an etching process.~~

- ~~16. Method according to claim 1 characterized in that the etching process is a plasma etching process.~~
17. Method according to claim 1 characterized  
5 in that the illumination beam (51) is scanned in a first direction across the holographic recording medium (79 ) and the mask (73), respectively , stepping the illumination (51) beam in a second direction perpendicular to the first direction, and then scanning the beam (51)  
10 again in the first direction and so on, such that the reference and object beams (75,74) travel simultaneously across the first face or the substrate (77) in optical contact with the first face;
- 15 18. Method according to claim 1 characterized in that the gap between the holographic recording layer and the mask is determined, e.g. interferometrically, and then the distance between the hologram and the recording medium adjusted to a  
20 predetermined value.
- ~~19. Method according to claims 1 to 18 characterized in that in the hologram reconstruction process the distance between the hologram and the  
25 substrate onto which the holographically recorded image is to be reconstructed is adjusted to the value as maintained between the holographic recording layer and the mask in the hologram formation process.~~
- 30 20. Method according to claim 1 characterized in that the reference beam is directed to a second face of the coupling element in a way that the

condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

21. Use of the method according to claim 1 for recording features of less than  $1\ \mu\text{m}$ , preferably less than  $0.5\ \mu\text{m}$ , contained in a mask in a hologram for use in microlithography.

22. Method of forming a hologram from a information containing mask, comprising the following steps:

- arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
- arranging a information containing mask in a spaced relationship and parallel to the substrate;
- generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
- directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;

further including the steps of

- employing a photoresist as the holographic recording medium;
- directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is



~~less than 45°, preferably less than 42° and most preferably less than 40°;~~

~~- arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.~~

~~23. Method according to claim 22 characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.~~

~~24. Method according to claim 22~~

25. Total internal reflection holographic recording

apparatus for recording a hologram from a mask, comprising

- an optical coupling element for receiving a substrate on a first face;

- a substrate bearing a holographic recording medium, the substrate being in optical contact with said first face of the optical coupling element,

- at least one light source for generating a light beam;  
- optical means for generating a collimated light beam of a selected cross-section;

- means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;

- means for directing the reference light beam at a second

face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;

5 - means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;

10 characterized in that

- the holographic recording medium is a photoresist; and  
- means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal.

20 26. Apparatus according to claim 25 characterized in that the at least one light source is a laser light source emitting light of a wavelength below 300nm, and preferably of a wavelength between about 150 and 260 nm; and preferably between about 190 and 254 nm.

27. Apparatus according to claim 25, characterized in that the photoresist material is such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .

28. Apparatus according to claim 25  
characterized in that the photoresist material is such  
that that its contrast described by its gamma factor  
satisfies the condition  $\gamma < 3$ .
- 5
29. Apparatus according to claim 25  
characterized in that a combination of polarisation angles  
of between 37 to 44°, preferably 39° for the reference beam  
and - 43 to -47°, preferably 45° for the object beam are  
10 applied.
30. Apparatus according to claim 25  
characterized in that means are provided for adjusting the  
intensities of the object and reference beams such that  
15 the intensity of the object beam exceeds that of the  
reference beam.
- ~~31. Apparatus according to claim 25  
characterized in that the intensity of the object beam  
20 exceeds that of the reference beam by at least of a factor  
2 preferably by a factor of about 4.~~
32. Apparatus according to claim 25  
characterized in that the thickness of the photoresist  
25 layer is less than 500 nm, preferably between 100 and 300  
nm and most preferably between 200 and 300 nm.
- ~~33. Apparatus according to claim 25  
characterized in that means are provided for scanning and  
30 stepping the incident light beam in a raster scan across  
the beam splitting means in a first and in a second  
direction, respectively, such that the reference and~~

~~object beams travel simultaneously across the first face  
or the substrate in optical contact with the first face;~~

34. Apparatus according to ~~claim 25~~  
5 ~~; further comprising~~  
- means for measuring the gap between the hologram and a  
wafer being arranged in a spaced relationship to the  
hologram; and  
- means for adjusting the parallelism and/or separation  
10 between the hologram and the wafer.
35. Apparatus according to ~~claim 25 to~~  
34 further characterized in that the directing means for  
the reference light beam further arranges that the angle  
15 of incidence of the reference beam in the holographic  
recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$   
and most preferably less than  $40^\circ$ .
36. Apparatus according to ~~claim 25 to~~  
20 35 characterized in that the photoresist employed has a  
refractive index at the exposure wavelength of greater  
than 1.6 and preferably greater than 1.7.
37. Total internal reflection holographic recording  
25 apparatus or system for recording a hologram from a mask,  
comprising  
- an optical coupling element for receiving a substrate on  
a first face;  
- a substrate bearing a holographic recording medium, the  
30 substrate being in optical contact with said first face of  
the optical coupling element,  
- at least one light source for generating a light beam;

- 29 -

- optical means for generating a collimated light beam of a selected cross-section;
  - means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
  - means for directing the reference light beam at a second face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;
  - means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;
- characterized in that
- the holographic recording medium is a photoresist;
  - means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal; and
  - in that the directing means for the reference light beam further arranges that the angle of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

- 30 -

~~38. Apparatus according to claim 37~~

~~39. Hologram recorded in a recording medium according to  
5 claim 1~~

Clean Version as AmendedClaims:

1. Method of forming a hologram from a information containing mask, comprising the following steps:
  - 5 - arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
  - arranging a information containing mask in a spaced relationship and parallel to the substrate;
  - 10 - generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
  - - directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled
  - 15 - directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;
  - 20 further including the steps of
  - employing a photoresist as the holographic recording medium; and
  - arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are
  - 25 substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.
- 30 2. Method according to claim 1, characterized in that substantially only the transmission hologram is recorded in the holographic recording layer.

3. Method according to claim 1 , characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

5

4. Method according to claim 1 , characterized in that the plane of polarisation of the object beam is at 45° to the plane of incidence of the reference beam at the holographic recording layer.

10

5. Method according to claim 1 , characterized in that the photoresist material is selected such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .

15

6. Method according to claim 1 , characterized in that the photoresist is selected such that its contrast described by its gamma-value satisfies the condition  $\gamma < 3$ .

20

25

8. Method according to claim 1 , characterized in that laser light of a wavelength below 300nm, and preferably of a wavelength between 150 and 260 nm for recording the hologram is used.

30



5

10

11. Method according to claim 1, characterized in that the intensity of the reference beam exceeds that of the object beam.

15

13. Method according to claim 1, characterized in that the intensity ratio of the object and reference beams is between 3:1 and 5:1, and preferably about 4:1.

14. Method according to claim 1, characterized in that the thickness of the photoresist layer is less than 500 nm, preferably between 100 and 300 nm and most preferably between 200 and 300 nm.

30

17. Method according to claim 1 characterized  
5 in that the illumination beam (51) is scanned in a first  
direction across the holographic recording medium (79 )  
and the mask (73), respectively , stepping the  
illumination (51) beam in a second direction perpendicular  
to the first direction, and then scanning the beam (51)  
10 again in the first direction and so on, such that the  
reference and object beams (75,74) travel simultaneously  
across the first face or the substrate (77) in optical  
contact with the first face,
- 15 18. Method according to claim 1.  
characterized in that the gap between the holographic  
recording layer and the mask is determined, e.g.  
interferometrically, and then the distance between the  
hologram and the recording medium adjusted to a  
20 predetermined value.
- 25
- 30 20. Method according to claim 1  
characterized in that the reference beam is directed to a  
second face of the coupling element in a way that the

condition for total internal reflection at the interface  
between the recording medium and the ambient medium is  
fulfilled and so that the angle of incidence of the beam  
in the recording layer is less than  $45^\circ$ , preferably less  
5 than  $42^\circ$  and most preferably less than  $40^\circ$ .

10

15

20

25

30

5

10

15

25. Total internal reflection holographic recording
- 20 apparatus for recording a hologram from a mask, comprising
- an optical coupling element for receiving a substrate on a first face;
  - a substrate bearing a holographic recording medium, the substrate being in optical contact with said first face of
  - 25 the optical coupling element,
  - at least one light source for generating a light beam;
  - optical means for generating a collimated light beam of a selected cross-section;
  - means, e.g. a beam-splitter, prism or the like, for
  - 30 generating two coherent light beams, a reference light beam and an object light beam;
  - means for directing the reference light beam at a second

face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;

5 - means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;

10 characterized in that

- the holographic recording medium is a photoresist; and  
- means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal.

20  
26. Apparatus according to claim 25 characterized in that the at least one light source is a laser light source emitting light of a wavelength below 300nm, and preferably of a wavelength between about 150 and 260 nm; and preferably between about 190 and 254 nm.

5

29. Apparatus according to claim 25 ,  
characterized in that a combination of polarisation angles  
of between 37 to 44°, preferably 39° for the reference beam  
and - 43 to -47°, preferably 45° for the object beam are  
10 applied.

30. Apparatus according to claim 25  
characterized in that means are provided for adjusting the  
intensities of the object and reference beams such that  
15 the intensity of the object beam exceeds that of the  
reference beam.

20

32. Apparatus according to claim 25  
characterized in that the thickness of the photoresist  
25 layer is less than 500 nm, preferably between 100 and 300  
nm and most preferably between 200 and 300 nm.

30

5

10

35. Apparatus according to claim 25 to 34 further characterized in that the directing means for the reference light beam further arranges that the angle of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

20

37. Total internal reflection holographic recording apparatus or system for recording a hologram from a mask, comprising

- an optical coupling element for receiving a substrate on a first face,
- a substrate bearing a holographic recording medium, the substrate being in optical contact with said first face of the optical coupling element,
- at least one light source for generating a light beam,

- optical means for generating a collimated light beam of a selected cross-section;
  - means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
  - means for directing the reference light beam at a second face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;
  - means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;
- characterized in that
- the holographic recording medium is a photoresist;
  - means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal; and
  - in that the directing means for the reference light beam further arranges that the angle of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .



10009944 10/009944

JCO5 Rec'd PCT/PTO 11 DEC 2001

Docket: HOLTR-400

IN THE UNITED STATES DESIGNATED/ELECTED OFFICE  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor : Woo-Sung Han  
Serial No. : None yet (US of PCT/IB00/00794)  
Filed : Concurrently Herewith  
For : Method And Apparatus For Recording A  
Hologram From A Mask Pattern By The Use Of  
Total Internal Reflection Holography And  
Hologram Manufactured By The Method

Hon. Commissioner of Patents & Trademarks  
Washington DC 20231

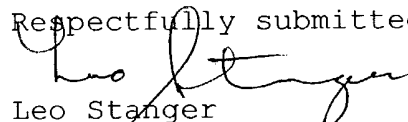
PRELIMINARY AMENDMENT

Sir:

Prior to an office action, please amend this  
application according to the attached "Claims As Amended"  
and "Claims With Amendments"

A favorable action is solicited.

Respectfully submitted.

  
Leo Stanger  
Registration No. 19,188

Stanger & Dreyfus, P.C.  
PO Box 1455  
382 Springfield Avenue  
Summit, NJ 07901

Tel 908-277-8588  
Fax 908-277-1487

Claims: *Showing amendments*

1. Method of forming a hologram from a information containing mask, comprising the following steps:
  - 5     - arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
  - arranging a information containing mask in a spaced relationship and parallel to the substrate;
  - 10    - generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
  - directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording
  - 15    medium and the ambient medium is fulfilled
  - directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;
  - further including the steps of
  - 20    - employing a photoresist as the holographic recording medium; and
  - arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are
  - 25    substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.
- 30 2. Method according to claim 1, characterized in that substantially only the transmission hologram is recorded in the holographic recording layer.

- 21 -

3. Method according to claim 1 ~~or 2~~, characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

5

4. Method according to claim 1 ~~or 3~~, characterized in that the plane of polarisation of the object beam is at 45° to the plane of incidence of the reference beam at the holographic recording layer.

10

5. Method according to ~~any of claims 1 to 4~~, characterized in that the photoresist material is selected such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .

15

6. Method according to ~~any of claims 1 to 5~~, characterized in that the photoresist is selected such that its contrast described by its gamma-value satisfies the condition  $\gamma < 3$ .

20 7. Method according to ~~any of claims 1 to 6~~, characterized in the photoresist is selected such that its resolution described by the smallest period of grating that can be optically recorded in the material is with a modulation depth  $(d_{\max} - d_{\min}) / (d_{\max} + d_{\min}) > 25\%$  satisfies the condition

25  $\Lambda < 200 \text{ nm}$ .

8. Method according to ~~any of claims 1 to 7~~, characterized in that laser light of a wavelength below 300nm, and preferably of a wavelength between 150 and 260 nm for recording the hologram is used.

30

- 22 -

9. Method according to ~~any of claims 1 to 8~~, characterized in the polarisation angles are selected according to the refractive index of the photoresist.
- 5 10. Method according to ~~any of claims 1 to 9~~, characterized in that a combination of polarisation angles of between 37 to 44°, preferably 39° for the reference beam and -43 to -47°, preferably -45° for the object beam with respect to the plane of incidence are applied.
- 10 11. Method according to ~~any of claims 1 to 10~~, characterized in that the intensity of the reference beam exceeds that of the object beam.
- 15 12. Method according to ~~any of claims 1 to 11~~, characterized in that the intensity of the reference beam exceeds that of the object beam by a factor 2, and preferably is 4 : 1.
- 20 13. Method according to ~~any of claims 1 to 12~~, characterized in that the intensity ratio of the object and reference beams is between 3:1 and 5:1, and preferably about 4:1.
- 25 14. Method according to ~~any of claims 1 to 13~~, characterized in that the thickness of the photoresist layer is less than 500 nm, preferably between 100 and 300 nm and most preferably between 200 and 300 nm.
- 30 15. Method according to ~~any of claims 1 to 14~~, characterized in that the image recorded in the photoresist as surface relief hologram is transferred into the substrate material by an etching process.

- 23 -

16. Method according to ~~any of claims 1 to 15~~, characterized in that the etching process is a plasma etching process.
17. Method according to ~~any of claims 1 to 16~~, characterized in that the illumination beam (51) is scanned in a first direction across the holographic recording medium (79 ) and the mask (73), respectively , stepping the illumination (51) beam in a second direction perpendicular to the first direction, and then scanning the beam (51) again in the first direction and so on, such that the reference and object beams (75,74) travel simultaneously across the first face or the substrate (77) in optical contact with the first face;
18. Method according to ~~any of the preceding claims 1 to 17~~ characterized in that the gap between the holographic recording layer and the mask is determined, e.g. interferometrically, and then the distance between the hologram and the recording medium adjusted to a predetermined value.
19. Method according to ~~any of the preceding claims 1 to 18~~ characterized in that in the hologram reconstruction process the distance between the hologram and the substrate onto which the holographically recorded image is to be reconstructed is adjusted to the value as maintained between the holographic recording layer and the mask in the hologram formation process.
20. Method according to ~~any of the preceding claims 1 to 19~~ characterized in that the reference beam is directed to a second face of the coupling element in a way that the

- 24 -

condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

21. Use of the method according to ~~any of claims 1 to 19~~ for recording features of less than  $1\text{ }\mu\text{m}$ , preferably less than  $0.5\text{ }\mu\text{m}$ , contained in a mask in a hologram for use in microlithography.

22. Method of forming a hologram from a information containing mask, comprising the following steps:

- arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
- arranging a information containing mask in a spaced relationship and parallel to the substrate;
- generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
- directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;

further including the steps of

- employing a photoresist as the holographic recording medium;
- directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is

- 25 -

less than 45°, preferably less than 42° and most preferably less than 40°;

- arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.

23. Method according to claim 22 characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

24. Method according to claim 22 ~~or 23 and any of claims 2 to 18.~~

25. Total internal reflection holographic recording apparatus for recording a hologram from a mask, comprising

- an optical coupling element for receiving a substrate on a first face;
- a substrate bearing a holographic recording medium, the substrate being in optical contact with said first face of the optical coupling element,
- at least one light source for generating a light beam;
- optical means for generating a collimated light beam of a selected cross-section;
- means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
- means for directing the reference light beam at a second

- 26 -

face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;

- means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;

characterized in that

- the holographic recording medium is a photoresist; and  
- means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal.

26. Apparatus according to claim 25 characterized in that the at least one light source is a laser light source emitting light of a wavelength below 300nm, and preferably of a wavelength between about 150 and 260 nm; and preferably between about 190 and 254 nm.

27. Apparatus according to claim 25 ~~or 26~~, characterized in that the photoresist material is such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .



- 27 -

28. Apparatus according to ~~any of claims 25 to 27~~,  
characterized in that the photoresist material is such  
that that its contrast described by its gamma factor  
satisfies the condition  $\gamma < 3$ .

5

29. Apparatus according to ~~any of claims 25 to 28~~,  
characterized in that a combination of polarisation angles  
of between 37 to 44°, preferably 39° for the reference beam  
and - 43 to -47°, preferably 45° for the object beam are  
applied.

10

30. Apparatus according to ~~any of claims 25 to 29~~,  
characterized in that means are provided for adjusting the  
intensities of the object and reference beams such that  
the intensity of the object beam exceeds that of the  
reference beam.

15

31. Apparatus according to ~~any of claims 25 to 30~~,  
characterized in that the intensity of the object beam  
exceeds that of the reference beam by at least of a factor  
2 preferably by a factor of about 4.

20

32. Apparatus according to ~~any of claims 25 to 31~~,  
characterized in that the thickness of the photoresist  
layer is less than 500 nm, preferably between 100 and 300  
nm and most preferably between 200 and 300 nm.

25

33. Apparatus according to ~~any of claims 25 to 32~~,  
characterized in that means are provided for scanning and  
stepping the incident light beam in a raster scan across  
the beam splitting means in a first and in a second  
direction, respectively, such that the reference and

30

- 28 -

object beams travel simultaneously across the first face  
or the substrate in optical contact with the first face;

34. Apparatus according to ~~any of the preceding claims 25 to~~  
5     ~~33~~ further comprising  
      - means for measuring the gap between the hologram and a  
      wafer being arranged in a spaced relationship to the  
      hologram; and  
      - means for adjusting the parallelism and/or separation  
10     between the hologram and the wafer.

35. Apparatus according to ~~any of the preceding claims 25 to~~  
      ~~34~~ further characterized in that the directing means for  
      the reference light beam further arranges that the angle  
15     of incidence of the reference beam in the holographic  
      recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$   
      and most preferably less than  $40^\circ$ .

36. Apparatus according to ~~any of the preceding claims 25 to~~  
20     ~~35~~ characterized in that the photoresist employed has a  
      refractive index at the exposure wavelength of greater  
      than 1.6 and preferably greater than 1.7.

37. Total internal reflection holographic recording  
25     apparatus or system for recording a hologram from a mask,  
      comprising  
      - an optical coupling element for receiving a substrate on  
      a first face;  
      - a substrate bearing a holographic recording medium, the  
30     substrate being in optical contact with said first face of  
      the optical coupling element,  
      - at least one light source for generating a light beam;

- 29 -

- optical means for generating a collimated light beam of a selected cross-section;
  - means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
  - means for directing the reference light beam at a second face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;
  - means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;
- characterized in that
- the holographic recording medium is a photoresist;
  - means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal; and
  - in that the directing means for the reference light beam further arranges that the angle of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

- 30 -

38. Apparatus according to claim 37 ~~and any of claims 26 to 26.~~

39. Hologram recorded in a recording medium according to  
5 ~~claims 1 to 20 or claims 22 to 24.~~

- 20 -

claims: *As amended*

1. Method of forming a hologram from a information containing mask, comprising the following steps:
  - 5 - arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
  - arranging a information containing mask in a spaced relationship and parallel to the substrate;
  - 10 - generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
  - - directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled
  - 15 - directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;
  - further including the steps of
  - 20 - employing a photoresist as the holographic recording medium; and
  - arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are
  - 25 substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.
- 30 2. Method according to claim 1, characterized in that substantially only the transmission hologram is recorded in the holographic recording layer.



- 22 -

9. Method according to claim 1, characterized in the polarisation angles are selected according to the refractive index of the photoresist.
- 5 10. Method according to claim 1, characterized in that a combination of polarisation angles of between 37 to 44°, preferably 39° for the reference beam and -43 to -47°, preferably -45° for the object beam with respect to the plane of incidence are applied.
- 10 11. Method according to claim 1, characterized in that the intensity of the reference beam exceeds that of the object beam.
- 15 12. Method according to claim 1, characterized in that the intensity of the reference beam exceeds that of the object beam by a factor 2, and preferably is 4 : 1.
- 20 13. Method according to claim 1, characterized in that the intensity ratio of the object and reference beams is between 3:1 and 5:1, and preferably about 4:1.
- 25 14. Method according to claim 1 to 13, characterized in that the thickness of the photoresist layer is less than 500 nm, preferably between 100 and 300 nm and most preferably between 200 and 300 nm.
- 30 15. Method according to claim 1 to 14, characterized in that the image recorded in the photoresist as surface relief hologram is transferred into the substrate material by an etching process.

- 23 -

16. Method according to claim 1, characterized in that the etching process is a plasma etching process.
17. Method according to claim 1, characterized in that the illumination beam (51) is scanned in a first direction across the holographic recording medium (79) and the mask (73), respectively, stepping the illumination (51) beam in a second direction perpendicular to the first direction, and then scanning the beam (51) again in the first direction and so on, such that the reference and object beams (75,74) travel simultaneously across the first face of the substrate (77) in optical contact with the first face;
18. Method according to any of the preceding claim 1 characterized in that the gap between the holographic recording layer and the mask is determined, e.g. interferometrically, and then the distance between the hologram and the recording medium adjusted to a predetermined value.
19. Method according to claim 1 characterized in that in the hologram reconstruction process the distance between the hologram and the substrate onto which the holographically recorded image is to be reconstructed is adjusted to the value as maintained between the holographic recording layer and the mask in the hologram formation process.
20. Method according to claim 1 characterized in that the reference beam is directed to a second face of the coupling element in a way that the



- 24 -

condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

21. Use of the method according to claim 1 for recording features of less than  $1\text{ }\mu\text{m}$ , preferably less than  $0.5\text{ }\mu\text{m}$ , contained in a mask in a hologram for use in microlithography.
22. Method of forming a hologram from a information containing mask, comprising the following steps:
- arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
  - arranging a information containing mask in a spaced relationship and parallel to the substrate;
  - generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
  - directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;
- further including the steps of
- employing a photoresist as the holographic recording medium;
  - directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is

- 25 -

less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ ;

- arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.

10

23. Method according to claim 22 characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

15

24. Method according to claim 22

20

25. Total internal reflection holographic recording

apparatus for recording a hologram from a mask, comprising

- an optical coupling element for receiving a substrate on a first face;
- a substrate bearing a holographic recording medium, the substrate being in optical contact with said first face of the optical coupling element,
- at least one light source for generating a light beam;
- optical means for generating a collimated light beam of a selected cross-section;
- means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
- means for directing the reference light beam at a second

30

- 26 -

face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;

- means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;

characterized in that

- the holographic recording medium is a photoresist; and

- means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal.

26. Apparatus according to claim 25 characterized in that the at least one light source is a laser light source emitting light of a wavelength below 300nm, and preferably of a wavelength between about 150 and 260 nm; and preferably between about 190 and 254 nm.

27. Apparatus according to claim 25, characterized in that the photoresist material is such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .

- 27 -

28. Apparatus according to claim 25  
characterized in that the photoresist material is such  
that that its contrast described by its gamma factor  
satisfies the condition  $\gamma < 3$ .
- 5
29. Apparatus according to claim 25  
characterized in that a combination of polarisation angles  
of between 37 to 44°, preferably 39° for the reference beam  
and - 43 to -47°, preferably 45° for the object beam are  
10 applied.
30. Apparatus according to claim 25  
characterized in that means are provided for adjusting the  
intensities of the object and reference beams such that  
15 the intensity of the object beam exceeds that of the  
reference beam.
31. Apparatus according to claim 25  
characterized in that the intensity of the object beam  
20 exceeds that of the reference beam by at least of a factor  
2 preferably by a factor of about 4.
32. Apparatus according to claim 25  
characterized in that the thickness of the photoresist  
25 layer is less than 500 nm, preferably between 100 and 300  
nm and most preferably between 200 and 300 nm.
33. Apparatus according to claim 25  
characterized in that means are provided for scanning and  
30 stepping the incident light beam in a raster scan across  
the beam splitting means in a first and in a second  
direction, respectively, such that the reference and

- 28 -

object beams travel simultaneously across the first face  
or the substrate in optical contact with the first face;

34. Apparatus according to claim 25  
5 further comprising  
- means for measuring the gap between the hologram and a  
wafer being arranged in a spaced relationship to the  
hologram; and  
- means for adjusting the parallelism and/or separation  
10 between the hologram and the wafer.

35. Apparatus according to claim 25 to  
34 further characterized in that the directing means for  
the reference light beam further arranges that the angle  
15 of incidence of the reference beam in the holographic  
recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$   
and most preferably less than  $40^\circ$ .

36. Apparatus according to claim 25 to  
20 35 characterized in that the photoresist employed has a  
refractive index at the exposure wavelength of greater  
than 1.6 and preferably greater than 1.7.

37. Total internal reflection holographic recording  
25 apparatus or system for recording a hologram from a mask,  
comprising  
- an optical coupling element for receiving a substrate on  
a first face;  
- a substrate bearing a holographic recording medium, the  
30 substrate being in optical contact with said first face of  
the optical coupling element,  
- at least one light source for generating a light beam;

- 29 -

- optical means for generating a collimated light beam of a selected cross-section;
  - means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
  - means for directing the reference light beam at a second face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;
  - means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;
- characterized in that
- the holographic recording medium is a photoresist;
  - means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal; and
  - in that the directing means for the reference light beam further arranges that the angle of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

- 30 -

38. Apparatus according to claim 37

39. Hologram recorded in a recording medium according to  
5 claim 1

claims: *Showing amendments*

1. Method of forming a hologram from a information containing mask, comprising the following steps:
- 5     - arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
- arranging a information containing mask in a spaced relationship and parallel to the substrate;
- 10    - generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
- directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording
- 15    medium and the ambient medium is fulfilled
- directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;
- further including the steps of
- 20    - employing a photoresist as the holographic recording medium; and
- arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are
- 25    substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.
- 30    2. Method according to claim 1, characterized in that substantially only the transmission hologram is recorded in the holographic recording layer.



- 21 -

3. Method according to claim 1 ~~or 2~~, characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

5

4. Method according to claim 1 ~~or 3~~, characterized in that the plane of polarisation of the object beam is at 45° to the plane of incidence of the reference beam at the holographic recording layer.

10

5. Method according to ~~any of claims 1 to 4~~, characterized in that the photoresist material is selected such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .

15

6. Method according to ~~any of claims 1 to 5~~, characterized in that the photoresist is selected such that its contrast described by its gamma-value satisfies the condition  $\gamma < 3$ .

20 7. Method according to ~~any of claims 1 to 6~~, characterized in the photoresist is selected such that its resolution described by the smallest period of grating that can be optically recorded in the material is with a modulation depth  $(d_{\max} - d_{\min}) / (d_{\max} + d_{\min}) > 25\%$  satisfies the condition  $\Lambda < 200 \text{ nm}$ .

25

8. Method according to ~~any of claims 1 to 7~~, characterized in that laser light of a wavelength below 300nm, and preferably of a wavelength between 150 and 260 nm for recording the hologram is used.

30

- 22 -

9. Method according to ~~any of claims 1 to 8~~, characterized in the polarisation angles are selected according to the refractive index of the photoresist.
- 5 10. Method according to ~~any of claims 1 to 9~~, characterized in that a combination of polarisation angles of between 37 to 44°, preferably 39° for the reference beam and - 43 to -47°, preferably -45° for the object beam with respect to the plane of incidence are applied.
- 10 11. Method according to ~~any of claims 1 to 10~~, characterized in that the intensity of the reference beam exceeds that of the object beam.
- 15 12. Method according to ~~any of claims 1 to 11~~, characterized in that the intensity of the reference beam exceeds that of the object beam by a factor 2, and preferably is 4 : 1.
- 20 13. Method according to ~~any of claims 1 to 12~~, characterized in that the intensity ratio of the object and reference beams is between 3:1 and 5:1, and preferably about 4:1.
- 25 14. Method according to ~~any of claims 1 to 13~~, characterized in that the thickness of the photoresist layer is less than 500 nm, preferably between 100 and 300 nm and most preferably between 200 and 300 nm.
- 30 15. Method according to ~~any of claims 1 to 14~~, characterized in that the image recorded in the photoresist as surface relief hologram is transferred into the substrate material by an etching process.

- 23 -

16. Method according to ~~any of claims 1 to 15~~, characterized in that the etching process is a plasma etching process.
17. Method according to ~~any of claims 1 to 16~~, characterized in that the illumination beam (51) is scanned in a first direction across the holographic recording medium (79 ) and the mask (73), respectively , stepping the illumination (51) beam in a second direction perpendicular to the first direction, and then scanning the beam (51) again in the first direction and so on, such that the reference and object beams (75,74) travel simultaneously across the first face or the substrate (77) in optical contact with the first face;
18. Method according to ~~any of the preceding claims 1 to 17~~ characterized in that the gap between the holographic recording layer and the mask is determined, e.g. interferometrically, and then the distance between the hologram and the recording medium adjusted to a predetermined value.
19. Method according to ~~any of the preceding claims 1 to 18~~ characterized in that in the hologram reconstruction process the distance between the hologram and the substrate onto which the holographically recorded image is to be reconstructed is adjusted to the value as maintained between the holographic recording layer and the mask in the hologram formation process.
20. Method according to ~~any of the preceding claims 1 to 19~~ characterized in that the reference beam is directed to a second face of the coupling element in a way that the

- 24 -

condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

21. Use of the method according to ~~any of claims 1 to 19~~ for recording features of less than  $1\ \mu\text{m}$ , preferably less than  $0.5\ \mu\text{m}$ , contained in a mask in a hologram for use in microlithography.

22. Method of forming a hologram from a information containing mask, comprising the following steps:

- arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
- arranging a information containing mask in a spaced relationship and parallel to the substrate;
- generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
- directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;

further including the steps of

- employing a photoresist as the holographic recording medium;
- directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is

- 25 -

less than 45°, preferably less than 42° and most preferably less than 40°;

- arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.

23. Method according to claim 22 characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

24. Method according to claim 22 ~~or 23 and any of claims 2 to 18.~~

25. Total internal reflection holographic recording apparatus for recording a hologram from a mask, comprising

- an optical coupling element for receiving a substrate on a first face;
- a substrate bearing a holographic recording medium, the substrate being in optical contact with said first face of the optical coupling element,
- at least one light source for generating a light beam;
- optical means for generating a collimated light beam of a selected cross-section;
- means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
- means for directing the reference light beam at a second

- 26 -

face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;

- means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;

characterized in that

- the holographic recording medium is a photoresist; and  
- means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal.

26. Apparatus according to claim 25 characterized in that the at least one light source is a laser light source emitting light of a wavelength below 300nm, and preferably of a wavelength between about 150 and 260 nm; and preferably between about 190 and 254 nm.

27. Apparatus according to claim 25 ~~or 26~~, characterized in that the photoresist material is such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .

- 27 -

28. Apparatus according to ~~any of claims 25 to 27~~,  
characterized in that the photoresist material is such  
that that its contrast described by its gamma factor  
satisfies the condition  $\gamma < 3$ .

5

29. Apparatus according to ~~any of claims 25 to 28~~,  
characterized in that a combination of polarisation angles  
of between 37 to 44°, preferably 39° for the reference beam  
and - 43 to -47°, preferably 45° for the object beam are  
applied.

10

30. Apparatus according to ~~any of claims 25 to 29~~,  
characterized in that means are provided for adjusting the  
intensities of the object and reference beams such that  
the intensity of the object beam exceeds that of the  
reference beam.

15

31. Apparatus according to ~~any of claims 25 to 30~~,  
characterized in that the intensity of the object beam  
exceeds that of the reference beam by at least of a factor  
2 preferably by a factor of about 4.

20

32. Apparatus according to ~~any of claims 25 to 31~~,  
characterized in that the thickness of the photoresist  
layer is less than 500 nm, preferably between 100 and 300  
nm and most preferably between 200 and 300 nm.

25

33. Apparatus according to ~~any of claims 25 to 32~~,  
characterized in that means are provided for scanning and  
stepping the incident light beam in a raster scan across  
the beam splitting means in a first and in a second  
direction, respectively, such that the reference and

30

- 28 -

object beams travel simultaneously across the first face  
or the substrate in optical contact with the first face;

34. Apparatus according to ~~any of the preceding claims 25 to~~  
5 ~~33~~ further comprising
- means for measuring the gap between the hologram and a wafer being arranged in a spaced relationship to the hologram; and
  - means for adjusting the parallelism and/or separation
- 10 between the hologram and the wafer.
35. Apparatus according to ~~any of the preceding claims 25 to~~  
15 ~~34~~ further characterized in that the directing means for the reference light beam further arranges that the angle of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .
36. Apparatus according to ~~any of the preceding claims 25 to~~  
20 ~~35~~ characterized in that the photoresist employed has a refractive index at the exposure wavelength of greater than 1.6 and preferably greater than 1.7.
37. Total internal reflection holographic recording  
25 apparatus or system for recording a hologram from a mask, comprising
- an optical coupling element for receiving a substrate on a first face;
  - a substrate bearing a holographic recording medium, the
- 30 substrate being in optical contact with said first face of the optical coupling element,
- at least one light source for generating a light beam;



- 29 -

- optical means for generating a collimated light beam of a selected cross-section;
  - means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
  - means for directing the reference light beam at a second face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;
  - means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;
- characterized in that
- the holographic recording medium is a photoresist;
  - means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal; and
  - in that the directing means for the reference light beam further arranges that the angle of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

- 30 -

38. Apparatus according to claim 37 ~~and any of claims 26 to 36.~~

39. Hologram recorded in a recording medium according to  
5 ~~claims 1 to 20 or claims 22 to 24.~~

- 20 -

claims: *As amended*

1. Method of forming a hologram from a information containing mask, comprising the following steps:
  - 5 - arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
  - arranging a information containing mask in a spaced relationship and parallel to the substrate;
  - 10 - generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
  - - directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled
  - 15 - directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;
  - further including the steps of
  - 20 - employing a photoresist as the holographic recording medium; and
  - arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are
  - 25 substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.
- 30 2. Method according to claim 1, characterized in that substantially only the transmission hologram is recorded in the holographic recording layer.

- 21 -

3. Method according to claim 1, characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

5

4. Method according to claim 1, characterized in that the plane of polarisation of the object beam is at 45° to the plane of incidence of the reference beam at the holographic recording layer.

10

5. Method according to claim 1, characterized in that the photoresist material is selected such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .

15

6. Method according to claim 1, characterized in that the photoresist is selected such that its contrast described by its gamma-value satisfies the condition  $\gamma < 3$ .

20 7. Method according to claim 1, characterized in that the photoresist is selected such that its resolution described by the smallest period of grating that can be optically recorded in the material is with a modulation depth  $(d_{\max} - d_{\min}) / (d_{\max} + d_{\min}) > 25\%$  satisfies the condition  $\Lambda < 200 \text{ nm}$ .

25

8. Method according to claim 1, characterized in that laser light of a wavelength below 300nm, and preferably of a wavelength between 150 and 260 nm for recording the hologram is used.

30

- 22 -

9. Method according to claim 1, characterized in the polarisation angles are selected according to the refractive index of the photoresist.
- 5 10. Method according to claim 1, characterized in that a combination of polarisation angles of between 37 to 44°, preferably 39° for the reference beam and -43 to -47°, preferably -45° for the object beam with respect to the plane of incidence are applied.
- 10 11. Method according to claim 1, characterized in that the intensity of the reference beam exceeds that of the object beam.
- 15 12. Method according to claim 1, characterized in that the intensity of the reference beam exceeds that of the object beam by a factor 2, and preferably is 4 : 1.
- 20 13. Method according to claim 1, characterized in that the intensity ratio of the object and reference beams is between 3:1 and 5:1, and preferably about 4:1.
- 25 14. Method according to claim 1 to 13, characterized in that the thickness of the photoresist layer is less than 500 nm, preferably between 100 and 300 nm and most preferably between 200 and 300 nm.
- 30 15. Method according to claim 1 to 14, characterized in that the image recorded in the photoresist as surface relief hologram is transferred into the substrate material by an etching process.

- 23 -

16. Method according to claim 1, characterized in that the etching process is a plasma etching process.
17. Method according to claim 1, characterized in that the illumination beam (51) is scanned in a first direction across the holographic recording medium (79) and the mask (73), respectively, stepping the illumination (51) beam in a second direction perpendicular to the first direction, and then scanning the beam (51) again in the first direction and so on, such that the reference and object beams (75,74) travel simultaneously across the first face of the substrate (77) in optical contact with the first face;
18. Method according to any of the preceding claim 1 characterized in that the gap between the holographic recording layer and the mask is determined, e.g. interferometrically, and then the distance between the hologram and the recording medium adjusted to a predetermined value.
19. Method according to claim 1 characterized in that in the hologram reconstruction process the distance between the hologram and the substrate onto which the holographically recorded image is to be reconstructed is adjusted to the value as maintained between the holographic recording layer and the mask in the hologram formation process.
20. Method according to claim 1 characterized in that the reference beam is directed to a second face of the coupling element in a way that the

- 24 -

condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

21. Use of the method according to claim 1 for recording features of less than  $1\text{ }\mu\text{m}$ , preferably less than  $0.5\text{ }\mu\text{m}$ , contained in a mask in a hologram for use in microlithography.

22. Method of forming a hologram from a information containing mask, comprising the following steps:

- arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
- arranging a information containing mask in a spaced relationship and parallel to the substrate;
- generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
- directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;

further including the steps of

- employing a photoresist as the holographic recording medium;
- directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is

- 25 -

less than 45°, preferably less than 42° and most preferably less than 40°;

- arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.

10

23. Method according to claim 22 characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

15

24. Method according to claim 22

20

25. Total internal reflection holographic recording apparatus for recording a hologram from a mask, comprising

- an optical coupling element for receiving a substrate on a first face;
- a substrate bearing a holographic recording medium, the substrate being in optical contact with said first face of the optical coupling element,
- at least one light source for generating a light beam;
- optical means for generating a collimated light beam of a selected cross-section;
- means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
- means for directing the reference light beam at a second

30



- 26 -

face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;

- means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;

characterized in that

- the holographic recording medium is a photoresist; and  
- means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal.

26. Apparatus according to claim 25 characterized in that the at least one light source is a laser light source emitting light of a wavelength below 300nm, and preferably of a wavelength between about 150 and 260 nm; and preferably between about 190 and 254 nm.

27. Apparatus according to claim 25, characterized in that the photoresist material is such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .

- 27 -

28. Apparatus according to claim 25  
characterized in that the photoresist material is such  
that its contrast described by its gamma factor  
satisfies the condition  $\gamma < 3$ .
- 5
29. Apparatus according to claim 25  
characterized in that a combination of polarisation angles  
of between 37 to 44°, preferably 39° for the reference beam  
and - 43 to -47°, preferably 45° for the object beam are  
10 applied.
30. Apparatus according to claim 25  
characterized in that means are provided for adjusting the  
intensities of the object and reference beams such that  
15 the intensity of the object beam exceeds that of the  
reference beam.
31. Apparatus according to claim 25  
characterized in that the intensity of the object beam  
20 exceeds that of the reference beam by at least of a factor  
2 preferably by a factor of about 4.
32. Apparatus according to claim 25  
characterized in that the thickness of the photoresist  
25 layer is less than 500 nm, preferably between 100 and 300  
nm and most preferably between 200 and 300 nm.
33. Apparatus according to claim 25  
characterized in that means are provided for scanning and  
30 stepping the incident light beam in a raster scan across  
the beam splitting means in a first and in a second  
direction, respectively, such that the reference and

- 28 -

object beams travel simultaneously across the first face  
or the substrate in optical contact with the first face;

34. Apparatus according to claim 25  
5 further comprising  
- means for measuring the gap between the hologram and a  
wafer being arranged in a spaced relationship to the  
hologram; and  
- means for adjusting the parallelism and/or separation  
10 between the hologram and the wafer.
35. Apparatus according to claim 25 to  
34 further characterized in that the directing means for  
the reference light beam further arranges that the angle  
15 of incidence of the reference beam in the holographic  
recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$   
and most preferably less than  $40^\circ$ .
36. Apparatus according to claim 25 to  
20 35 characterized in that the photoresist employed has a  
refractive index at the exposure wavelength of greater  
than 1.6 and preferably greater than 1.7.
37. Total internal reflection holographic recording  
25 apparatus or system for recording a hologram from a mask,  
comprising  
- an optical coupling element for receiving a substrate on  
a first face;  
- a substrate bearing a holographic recording medium, the  
30 substrate being in optical contact with said first face of  
the optical coupling element,  
- at least one light source for generating a light beam;

- 29 -

- optical means for generating a collimated light beam of a selected cross-section;
  - means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
  - means for directing the reference light beam at a second face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;
  - means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;
- characterized in that
- the holographic recording medium is a photoresist;
  - means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal; and
  - in that the directing means for the reference light beam further arranges that the angle of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

- 30 -

38. Apparatus according to claim 37

39. Hologram recorded in a recording medium according to

5 claim 1

3/PRTS

10009944.082602

10/009944

JCS Rec'd PGTPTO 11 DEC 2007

Method and apparatus for recording a hologram from a mask pattern by the use of total internal reflection holography and hologram manufactured by the method

- 5 The present invention relates to a total internal reflection holographic apparatus and a method of forming a hologram and reconstructing an image therefrom.

- The principles of total internal reflection (TIR) holography  
10 have been described already in US 4,857,425. Since then many efforts have been made to make use of TIR holography in the microelectronics industries. Prior art references are e.g. US 4,917,497, US 4,966,428, 5,187,372, US 5,640,257 and European application no. 98300188 whose contents are herewith  
15 incorporated by reference.

- Frosch et al. (US 3,796,476) recorded TIR holograms of mask patterns using photographic emulsion, i.e. grains of silver halide dispersed in a gelatin film, as the holographic  
20 recording material. Such a material records information by modulating the bulk properties of the material (either its absorption or refractive index) and is referred to hereinafter as a "volume recording material".

- 25 Normally in TIR holography the three recording beams (object beam, incident reference beam and totally internally reflected beam) give rise to three holograms in the recording material. The interference between the incident reference beam and the object beams, produces a reflection hologram,  
30 the interference between the totally internally reflected reference beam and the object beam produces a transmission hologram and the interference between the incident reference

- 2 -

beam and the totally internally reflected reference beam produces a Lippmann hologram. Frosch et al. disclosed object and reference beams whose planes of polarisation they claimed to be orientated such that only one hologram is formed

5 (either the reflection hologram formed by interference of the object beam with the incident reference beam or the transmission hologram formed by the interference of the object beam with the reflected reference beam) for the purpose of avoiding the (perceived) problem of loss of

10 resolution due to shrinkage of the emulsion between recording and replay. According to Frosch et al., when both of the aforementioned holograms are present, shrinkage of the emulsion causes the images generated by the two holograms of Frosch et al. to shift relative to each other, and this

15 degrades the resolution.

Since 1974, when US 3,796,476 was published, no subsequent prior art on TIR holography directed at high resolution lithography has employed the polarisation scheme proposed by

20 Frosch et al. The reasons for this are as explained above: for volume holography, not only does the method not offer any useful purpose but also the scheme disclosed does not work as described.

25 The overwhelming part of the literature relating to the application of TIR holography to microlithography concerns volume holography. In particular, the holograms are generally recorded in photopolymer materials manufactured e.g. by DuPont Nemours. With this material the pattern in the mask is

30 recorded as a modulation of the refractive index in a layer of typically  $\sim 10 \mu\text{m}$  thickness. This material functions well for recording holograms using visible or near ultra-violet

- 3 -

light (i.e. down to a wavelength of ~350 nm). In contrast thereto, "surface-relief" holography records the mask pattern information as a modulation of thickness of the recording layer.

5

In 1988 Ross et al. reported on recording TIR holograms of mask patterns using a wavelength of 458 nm, S-polarisation (i.e. electric field vector perpendicular to the plane of incidence of the reference beam at the recording layer) for the object and reference beams and using the surface-relief material photoresist as the holographic recording material. They used an argon-ion laser operating at 458 nm as the light source. They were able to obtain hologram efficiencies of only ~ 5 % which they partly attributed to the problem of obtaining deep surface-relief structures in the photoresist because of the intensity distribution of the 3 interfering beams in the photoresist (object beam, incident reference beam and reflected reference beam) and the development process which preferentially etches the high intensity regions.

An approach for achieving higher resolution from TIR holographic lithography is to reduce the wavelength of the light source for recording and replay from the commonly used value of 364 nm to a value of, for instance, 248 nm or 193 nm which are in the deep ultra-violet part of the spectrum and are produced by krypton fluoride and argon fluoride excimer lasers respectively. These laser sources are widely used by the micro-electronics industry in lens-based lithographic systems. Volume holographic recording materials for such wavelengths are however not readily available.

30



- 4 -

It is an object of the present invention to provide an improved method and apparatus for forming a total internal reflection (TIR) hologram and reconstructing an image therefrom. In particular, it is an object to provide better  
5 resolution so that still smaller features can be recorded in a hologram and subsequently be reproduced therefrom.

According to the invention there is provided a method according to the pre-characterizing part of claim 1 wherein a  
10 photoresist is employed as the holographic recording medium and the planes of polarisation of the object and reference beams incident on the holographic recording medium are arranged such that their polarisation vectors are substantially mutually orthogonal in the holographic  
15 recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.

However, the present inventors have found that the contention  
20 of Frosch et al., namely that shrinkage causes a relative shift of the two images reconstructed from the two holograms, is not true. In fact, shrinkage of the emulsion does not cause either of the images to shift and thus there is no relative shift of the two.

25 The present inventors have further found that the teaching of Frosch et al. with respect to the planes of polarisation required of the object and reference beams to limit the number of holograms formed to just one is also, in fact,  
30 invalid. Frosch et al. assert that the plane of polarisation of the incident reference beam should be at an angle of  $45^\circ$  with respect to its plane of incidence and that the plane of

- 5 -

polarisation of the object beam should be parallel or orthogonal to the plane of polarisation of the incident reference beam. They state (US 3,796,476, col. 4 lines 35-42) that "this selection of the plane of polarisation of the  
5 (incident) reference beam  $B_1$  ensures that near the bordering angle of the total reflection - owing to the turning of the plane of polarisation by  $90^\circ$  - no interference pattern can form between the two reference beams  $B_1$  and  $B_2$ ". The authors of the present invention have found this statement to be  
10 incorrect in that the plane of polarisation selected for the reference beam is not rotated by  $90^\circ$  on total internal reflection but instead remains substantially unchanged and results in a strong interference pattern being formed between the two reference beams  $B_1$  and  $B_2$ .

15

Advantageously, substantially only the transmission hologram is recorded in the holographic recording layer. Surprisingly, this gives the best results as to resolution and contrast of the hologram. These findings are in contrast to the teaching  
20 of Frosch et al. (US 3,796,496) who teach to record the reflection hologram. By recording substantially only the transmission hologram, TIR holography can be used effectively for recording submicron features in surface relief holograms. Advantageously, the plane of polarisation of the object beam  
25 is at  $45^\circ$  to the plane of incidence of the reference beam at the holographic recording layer. This allows to further reduce the contribution to the reflection and Lippman holograms.

30 Advantageously, the photoresist material is selected such that its thickness ( $d$ ) and absorption ( $a$ ) meet the condition  $a * d < 1$ . Since the resist thickness ( $d$ ) is coupled with the

- 6 -

absorption coefficient ( $\alpha$ ) to determine the transmittance ( $T$ ) of the resist through the formula  $T = \exp(-4\pi\kappa/\lambda_0) \cdot \exp(-\alpha \cdot d)$ , the product  $\alpha \cdot d$  is of concern ( $\kappa$ =extinction coefficient,  $\lambda$  = wavelength). The photoresist should

5 preferably also be selected such that its contrast described by its gamma-value satisfies the condition  $\gamma < 3$ .

Advantageously, the resolution of the photoresist is selected such that its resolution described by the smallest period,  $\Lambda$ , of grating that can be optically recorded in the material  
10 with a modulation depth  $(d_{\max} - d_{\min}) / (d_{\max} + d_{\min}) > 25 \%$  should satisfy the condition  $\Lambda < 200$  nm. It has further been found that the best results can be obtained if the thickness of the photoresist layer is less than 500 nm, preferably between 100 and 300 nm and most preferably between 200 and 300 nm.

15

It has additionally been found that both positive and negative photoresists can be employed.

It is preferred that the laser light used has a wavelength of  
20 below 300nm, and preferably a wavelength of 248 nm or 193 nm. Further, it is advantageous that the intensity of the reference beam exceeds that of the object beam, by a factor 2, and preferably is 4 : 1.

25 For a better long-term stability of the hologram it is further advisable that the image recorded in the photoresist as a surface relief hologram be subsequently transferred into the underlying substrate material by an etching process, such as by plasma etching.

30

- 7 -

Although the hologram can be formed in a single exposure, preferably beams of a restricted cross-section are used and the hologram is formed by a scanning operation. The inventive process is particularly useful for transferring features of  
5 less than 1  $\mu\text{m}$ , preferably less than 0.5  $\mu\text{m}$ , from a mask into a hologram for use in microlithography.

Preferably, the angle of incidence of the beam in the recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$   
10 and most preferably less than  $40^\circ$ . By this arrangement the contribution to the reflection and Lippman holograms can be reduced to a minimum. Advantageously, a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

15

The present invention relates also to a total internal reflection holographic recording apparatus for recording a hologram from a mask, comprising

- an optical coupling element for receiving a substrate on  
20 a first face;
- a substrate bearing a holographic recording layer, the substrate being in optical contact with said first face of the optical coupling element,
- a mask bearing a pattern arranged in proximity and  
25 parallel to the holographic recording layer,
- a light source for generating a light beam;
- optical means for generating a collimated light beam of a selected cross-section;
- means, such as a beam-splitter, prism or the like, for  
30 dividing the collimated light beam into two coherent light beams, a reference light beam and an object light beam;
- means for directing the reference light beam at a second

- 8 -

face of the coupling element such that it illuminates the interface between the holographic recording layer and the ambient medium at an angle greater than the critical angle;

- means for directing the object light beam at the first  
5 face of the coupling element such that it overlaps the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face; characterized in that

- the holographic recording medium is a photoresist and  
10 - means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation  
15 vectors of the incident and totally internally reflected reference beams are also substantially orthogonal. Further advantageous features are defined in the sub-claims.

The coupling element is for instance a prism or a grating on  
20 a transparent plate such as a fused silica substrate as described in the co-pending European application no. EP 98300188 (published under no. EP 0 930 549). The coupling element disclosed in EP 0 930 549 is a substrate having a periodic grating structure on the first surface whose period,  
25 in relation to the incident angle and wavelength of the light and the refractive index of the plate material is such that only a zeroth and one first order beams of the light being incident on the first surface at a predetermined incident angle are transmitted into the plate and that the transmitted  
30 first diffraction order is essentially totally reflected at the second surface/air interface. Thus, the grating can behave like a prism in a TIR holographic process.

- 9 -

Advantageously the apparatus comprises means for measuring the gap between the holographic recording layer and the mask preferably at the center of the scanning illumination beam,  
5 and means for adjusting the separation between the holographic recording layer and the mask.

According to another independent aspect of the invention a method of forming a hologram from a information containing  
10 mask is provided, comprising the following steps:

- arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
- arranging a information containing mask in a spaced  
15 relationship and parallel to the substrate;
- generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
- directing the object beam through the mask to the substrate such that it overlaps with the reference beam in  
20 the holographic recording medium;

further including the steps of

- employing a photoresist as the holographic recording medium;
- directing the reference beam to a second face of the  
25 coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is less than 45°, preferably less than 42° and most preferably less  
30 than 40°;
- arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium

- 10 -

such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also  
5 substantially orthogonal.

The authors of the present invention have determined that with an angle of incidence for the reference beam within the holographic recording layer of  $45^\circ$ , which is the angle  
10 employed by Frosch et al. and also the angle generally employed in the field of TIR holography using volume recording materials, that no planes of polarisation of the incident reference and object beams exist that permit only or substantially only one hologram to be formed in the  
15 holographic recording layer.

The inventors have found that photoresist materials generally have higher refractive indices than the volume recording materials employed in the prior art (whose index is generally  
20  $\sim 1.5$ ) and this allows the angle of incidence of the reference beam in the recording layer to be significantly less than  $45^\circ$  without violating the condition for total internal reflection. Arranging that the angle of incidence of the reference beam is significantly less than an angle of  $45^\circ$  permits the planes  
25 of polarisation of the reference and object beams to be selected in order to suppress the Lippmann and reflection holograms so that substantially only the transmission hologram is formed.

30 The contrast of the Lippmann hologram  $C_{\text{Lipp}}$  is dependent on the polarisation vectors of the incident and reflected reference beams according to

- 11 -

$$C_{Lipp} = (P_{ir} \cdot P_{rr})$$

where  $P_{ir}$  and  $P_{rr}$  are the polarisation vectors of the  
5 incident and reflected reference beams. If we neglect  
polarisation rotation on total internal reflection (which is  
a valid approximation near the critical angle) then  $C_{Lipp}$  is  
minimized when

$$10 \quad \tan^2 \theta_r = \cos 2 \theta_{pr} \quad \text{equ. (1)}$$

where  $\theta_r$  is the angle the plane of polarisation of the  
reference beam makes with the plane of incidence of the  
reference beam at the holographic recording layer and where  
15  $\theta_{pr}$  is the angle of incidence of the reference beam in the  
photoresist.

Similarly, the contrast of the reflection hologram is  
dependent on

$$20 \quad C_{refl} = (P_{ir} \cdot P_o)$$

where  $P_o$  is the polarisation vector of the incident  
object beam and this is minimized when

$$25 \quad \tan \theta_r \tan \theta_o = -\cos \theta_{pr} \quad \text{equ. (2)}$$

Thus, equations (1) and (2) allow the planes of polarisation  
of the incident reference and object beams to be selected in  
30 order to that the transmission hologram is preferentially  
recorded in the holographic layer.

Let us take as an example a layer of photoresist of  
refractive index 1.8 on a transparent substrate of refractive  
35 index 1.5 and with the angle of incidence of the reference



- 12 -

beam in the substrate to be  $45^\circ$ . From Snell's law the angle of incidence of the reference beam in the photoresist,  $\theta_{pr}$ , is calculated to be :

5 
$$\theta_{pr} = 36^\circ$$

Hence, using equ. (1) above, the plane of polarisation of the incident reference beam should be oriented such that

10 
$$\theta_r = 29^\circ$$

and, using equ. (2), the plane of polarisation of the object beam should be oriented such that

15 
$$\theta_o = -56^\circ$$

Whereas the formulae and angles calculated above are applicable for masks containing line geometries oriented parallel to a single axis, in the case of masks containing grating structures in two orthogonal x and y directions, the inventors have found that advantageously the plane of polarisation of the object beam should be in the range  $-43^\circ$  to  $-47^\circ$  and preferably  $-45^\circ$  and that the plane of polarisation of the reference beam should again be calculated according to equ. 2 above. Thus, for the particular photoresist considered in the example above, the corresponding angle of polarisation of the reference beam should be in the range  $37^\circ$  to  $41^\circ$  and preferably  $39^\circ$ .

30 Advantageously, a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7. Further advantageous embodiments of the invention are defined in the subclaims.

- 13 -

Subject of the present invention is also a total internal reflection holographic recording apparatus for recording a hologram from a mask, comprising

- an optical coupling element for receiving a substrate on  
5 a first face;
- a substrate bearing a holographic recording layer, the substrate being in optical contact with said first face of the optical coupling element,
- a mask bearing a pattern arranged in proximity and  
10 parallel to the holographic recording layer,
- a light source for generating a light beam;
- optical means for generating a collimated light beam of a selected cross-section;
- means, such as a beam-splitter, prism or the like, for  
15 dividing the collimated light beam into two coherent light beams, a reference light beam and an object light beam;
- means for directing the reference light beam at a second face of the coupling element such that it illuminates the interface between the holographic recording layer and the  
20 ambient medium at an angle greater than the critical angle;
- means for directing the object light beam at the first face of the coupling element such that it overlaps the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face,
- 25 whereby the holographic recording medium is a photoresist and the directing means for the reference light beam further arranges that the angle of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$  and means are  
30 provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are

- 14 -

substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal. Further advantageous  
5 embodiments of the invention are defined in the dependent claims.

Advantageously a photoresist is selected whose refractive index is higher than a value of 1.6 and preferably higher  
10 than 1.7 at the wavelength of the light source.

For a more complete understanding of the present invention, reference is now made to the figures, like numerals being used for like and corresponding parts of the various  
15 drawings.

Fig.1 is a schematic view of a total internal reflection (TIR) holographic recording apparatus comprising a scanning stage for scanning an illumination beam in x and y direction (only x dimension shown);

Fig. 2 a view of the scanning stage from above;

Fig.3 the inventive TIR holographic recording system

Figure 1 shows a known TIR holographic system for forming an a hologram from a mask pattern. It comprises a prism 11 which  
20 a substrate 13 bearing a holographic recording layer 15 is index-matched by means of an appropriate matching fluid. The matching fluid is applied between prism 11 and substrate 13 and exhibits the same refractive index as the prism 11 and substrate material so that a light beam which passes from the

- 15 -

prism 11 into the substrate 13 preferably is not reflected at the prism/substrate interface.

For forming a hologram two light beams are necessary, an  
5 object beam 17 and a reference beam 19. The object and  
reference beams 17,19 are coherent laser beams which are  
derived from the same laser source. The normally narrow laser  
light beam is first preferably expanded and collimated by an  
expansion and collimating optics 21 to a beam of a diameter  
10 of about 15 to 20 mm by a known optical expansion means.  
Thereafter the expanded and collimated beam is directed by a  
mirror 23 towards a xy scanning stage 25. The two-axes xy  
scanning stage serves to deflect the collimated light beam 27  
such that the beam can traverse in a raster pattern  
15 essentially the entire prism face onto which the substrate 13  
bearing the recording medium 15 is arranged. For this purpose  
the scanning stage 25 (see figure 2) comprises a first mirror  
29 on a first carriage 31 movable in the x direction which  
deflects the light beam to a second mirror 33 on a second  
20 stage 35 moveable in the x direction that is also mounted to  
the first carriage. This second mirror 35 deflects the beam  
onto further large mirrors 37,39 such that the light beam  
enters the prism 11 through the hypotenuse face 41 and  
arrives at the substrate bearing face of the prism at an  
25 angle which is greater than the critical angle. For, the  
orientation of the stage system it is preferable that the  
beam be scanned in the x direction and stepped in the y  
direction (it also allows the beam to be scanned in the y  
direction and stepped in the x direction, though this is not  
30 desirable because of mechanical wear to the first stage).

- 16 -

The mirror 37 is semi-transparent and functions as beam splitter for generating the object beam 17. The object beam 17 is directed to mirror 43 which deflects the beam 17 towards the substrate 13 at normal incidence.

5

For forming the hologram a mask 45 containing a mask pattern 47 is placed parallel and in a spaced relationship to the substrate 13. The object beam 17 penetrates the mask 45 and the transmitted light of the object beam interferes with the reference beam 19.

10

For forming a large-size hologram the reference and object light beams are preferably scanned in an aligned relationship across the entire mask 45 and substrate 13 surfaces in a raster scan-and-step operation whereby the object and the reference beams 17,19 interfere with each other in the holographic recording medium 15 thereby forming the desired hologram.

15

In order that the object and reference beams 17, 19 remain superposed as they scan across the mask and recording layer, an additional prism 49 is provided in the light path of the reference beam which compresses the reference beam in one direction.

20  
25

The reconstruction of an image from the hologram requires that the direction of the reference light beam is reversed, i.e. being in the opposite direction to that of the reference beam in the hologram formation process. The interaction of the reversed light beam or reconstruction beam, with the hologram produces a positive image of the circuit pattern in the photosensitive layer or, for instance, a silicon wafer

30

- 17 -

placed at the same distance from the hologram as was the mask from the recording layer during the hologram formation process.

- 5 In order that the image generated from the hologram can be later printed in focus it is preferable that during the exposure the local gap between mask and recording layer where the beams are illuminating them is continuously measured and adjusted to a constant value. The apparatus and methodology  
10 for this are not described here since they are adequately described already in the prior-art.

Figure 3 shows an embodiment according to the present invention. The laser source in this case is a frequency-  
15 doubled argon ion laser emitting a beam at a wavelength of 248 nm. The transmissive components in the optical system including the beamsplitter, prisms, hologram substrate and lens are manufacture from fused silica which is transparent at the wavelength of 248 nm.

20

According to the invention a photoresist is selected as the holographic recording medium 15, in particular a 250 nm thick layer of the SNR 240 manufactured by Shipley. This resist has a refractive index of 1.8 at the exposure wavelength. The  
25 mirror 39 directs the reference beam into the prism 11 such that the angle of incidence of the beam in the photoresist layer is 36°. The planes of polarisation of the object and reference beams incident on the holographic recording medium are arranged such that their polarisation vectors are  
30 according to the values calculated in the example quoted earlier in the summary of the invention so that they are substantially mutually orthogonal in the holographic

- 18 -

recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal in order that the transmission hologram is preferentially recorded in the  
5 holographic recording layer. The latter is achieved by providing polarisation rotating plates 51,53 arranged in the light paths of the object and reference beams 17,19. Alternatively such polarisation rotating means for the object and reference beams might be integrated into the beamsplitter  
10 component.

A filter plate 55 is additionally included in the object beam path such that the object -t- reference beam intensity ratio is 1:4.  
15

The exposure parameters, namely the laser power, scanning speed and step size are selected in order that the depth of the surface-relief profile formed in the developed resist is preferably greater than 50 nm and optimally about 100 nm.  
20

To minimise scattering in the developed structure it is advisable that a slow and gentle development process be used in particular the developer MF322 manufactured by Shipley diluted 1:1 with water and that the solution be cooled to a  
25 temperature of  $\sim 9^{\circ}\text{C}$ . The development time of a 5 s can be employed. It is further recommended that the resist be prebaked at a temperature of  $130^{\circ}\text{C}$  prior to exposure to drive off solvents that can also result in increased scattering in the final structure. It is also recommended that its resist  
30 is coated using an enclosed chuck.

- 19 -

It is to be noted that for the purpose of the present invention scanning of the reference and object beams is not an essential feature and that, accordingly, also stationary expanded beams can be used as disclosed in US 4,966,428 to  
5 Phillips.

The present invention relates to a method and an apparatus or system for forming a hologram from a mask. According to the invention a photoresist is used as the holographic recording  
10 medium and the planes of polarisation of the object and reference beams incident on the holographic recording medium are arranged such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of  
15 the incident and totally internally reflected reference beams are also substantially orthogonal. Preferably the object and the incident reference beams as well as their polarisations are selected or adjusted that essentially just the transmission hologram is recorded in the holographic  
20 recording layer and that at least the reflection hologram is essentially suppressed.



- 20 -

Claims:

1. Method of forming a hologram from a information containing mask, comprising the following steps:
- 5     - arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
- arranging a information containing mask in a spaced relationship and parallel to the substrate;
- 10    - generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
- directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording
- 15    medium and the ambient medium is fulfilled
- directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;
- further including the steps of
- 20    - employing a photoresist as the holographic recording medium; and
- arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are
- 25    substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.
- 30    2. Method according to claim 1, characterized in that substantially only the transmission hologram is recorded in the holographic recording layer.

3. Method according to claim 1 or 2, characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

4. Method according to claim 1 or 3, characterized in that the plane of polarisation of the object beam is at  $45^\circ$  to the plane of incidence of the reference beam at the holographic recording layer.

5. Method according to any of claims 1 to 4, characterized in that the photoresist material is selected such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .

6. Method according to any of claims 1 to 5, characterized in that the photoresist is selected such that its contrast described by its gamma-value satisfies the condition  $\gamma < 3$ .

8. Method according to any of claims 1 to 7, characterized in that laser light of a wavelength below 300nm, and preferably of a wavelength between 150 and 260 nm for recording the hologram is used.

- 22 -

9. Method according to any of claims 1 to 8, characterized in the polarisation angles are selected according to the refractive index of the photoresist.

5 10. Method according to any of claims 1 to 9, characterized in that a combination of polarisation angles of between 37 to 44°, preferably 39° for the reference beam and -43 to -47°, preferably -45° for the object beam with respect to the plane of incidence are applied.

10

11. Method according to any of claims 1 to 10, characterized in that the intensity of the reference beam exceeds that of the object beam.

15 12. Method according to any of claims 1 to 11, characterized in that the intensity of the reference beam exceeds that of the object beam by a factor 2, and preferably is 4 : 1.

20 13. Method according to any of claims 1 to 12, characterized in that the intensity ratio of the object and reference beams is between 3:1 and 5:1, and preferably about 4:1.

25 14. Method according to any of claims 1 to 13, characterized in that the thickness of the photoresist layer is less than 500 nm, preferably between 100 and 300 nm and most preferably between 200 and 300 nm.

30 15. Method according to any of claims 1 to 14, characterized in that the image recorded in the photoresist as surface relief hologram is transferred into the substrate material by an etching process.

- 23 -

16. Method according to any of claims 1 to 15, characterized in that the etching process is a plasma etching process.
17. Method according to any of claims 1 to 16, characterized in that the illumination beam (51) is scanned in a first direction across the holographic recording medium (79 ) and the mask (73), respectively , stepping the illumination (51) beam in a second direction perpendicular to the first direction, and then scanning the beam (51) again in the first direction and so on, such that the reference and object beams (75,74) travel simultaneously across the first face or the substrate (77) in optical contact with the first face;
18. Method according to any of the preceding claims 1 to 17 characterized in that the gap between the holographic recording layer and the mask is determined, e.g. interferometrically, and then the distance between the hologram and the recording medium adjusted to a predetermined value.
19. Method according to any of the preceding claims 1 to 18 characterized in that in the hologram reconstruction process the distance between the hologram and the substrate onto which the holographically recorded image is to be reconstructed is adjusted to the value as maintained between the holographic recording layer and the mask in the hologram formation process.
20. Method according to any of the preceding claims 1 to 19 characterized in that the reference beam is directed to a second face of the coupling element in a way that the

- 24 -

condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

21. Use of the method according to any of claims 1 to 19 for recording features of less than  $1\text{ }\mu\text{m}$ , preferably less than  $0.5\text{ }\mu\text{m}$ , contained in a mask in a hologram for use in microlithography.

22. Method of forming a hologram from a information containing mask, comprising the following steps:

- arranging a substrate bearing a layer of a holographic recording medium on a first face of a coupling element and in optical contact therewith;
- arranging a information containing mask in a spaced relationship and parallel to the substrate;
- generating an illumination light beam and then splitting the light beam into an object beam and a reference beam;
- directing the object beam through the mask to the substrate such that it overlaps with the reference beam in the holographic recording medium;

further including the steps of

- employing a photoresist as the holographic recording medium;
- directing the reference beam to a second face of the coupling element in a way that the condition for total internal reflection at the interface between the recording medium and the ambient medium is fulfilled and so that the angle of incidence of the beam in the recording layer is

- 25 -

less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ ;

- 5 - arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are also substantially orthogonal.

10

23. Method according to claim 22 characterized in that a photoresist is employed whose refractive index at the exposure wavelength is greater than 1.6 and preferably greater than 1.7.

15

24. Method according to claim 22 or 23 and any of claims 2 to 18.

25. Total internal reflection holographic recording apparatus for recording a hologram from a mask, comprising
- 20 - an optical coupling element for receiving a substrate on a first face;
- a substrate bearing a holographic recording medium, the substrate being in optical contact with said first face of
- 25 the optical coupling element,
- at least one light source for generating a light beam;
- optical means for generating a collimated light beam of a selected cross-section;
- means, e.g. a beam-splitter, prism or the like, for
- 30 generating two coherent light beams, a reference light beam and an object light beam;
- means for directing the reference light beam at a second

- 26 -

face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;

- means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;

characterized in that

- the holographic recording medium is a photoresist; and  
- means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal.

26. Apparatus according to claim 25 characterized in that the at least one light source is a laser light source emitting light of a wavelength below 300nm, and preferably of a wavelength between about 150 and 260 nm; and preferably between about 190 and 254 nm.

27. Apparatus according to claim 25 or 26, characterized in that the photoresist material is such that its thickness (d) and absorption (a) meet the condition  $a * d < 1$ .

- 27 -

28. Apparatus according to any of claims 25 to 27,  
characterized in that the photoresist material is such  
that that its contrast described by its gamma factor  
satisfies the condition  $\gamma < 3$ .

5

29. Apparatus according to any of claims 25 to 28,  
characterized in that a combination of polarisation angles  
of between 37 to 44°, preferably 39° for the reference beam  
and - 43 to -47°, preferably 45° for the object beam are  
applied.

10

30. Apparatus according to any of claims 25 to 29,  
characterized in that means are provided for adjusting the  
intensities of the object and reference beams such that  
the intensity of the object beam exceeds that of the  
reference beam.

15

31. Apparatus according to any of claims 25 to 30,  
characterized in that the intensity of the object beam  
exceeds that of the reference beam by at least of a factor  
2 preferably by a factor of about 4.

20

32. Apparatus according to any of claims 25 to 31,  
characterized in that the thickness of the photoresist  
layer is less than 500 nm, preferably between 100 and 300  
nm and most preferably between 200 and 300 nm.

25

33. Apparatus according to any of claims 25 to 32,  
characterized in that means are provided for scanning and  
stepping the incident light beam in a raster scan across  
the beam splitting means in a first and in a second  
direction, respectively, such that the reference and

30



- 28 -

object beams travel simultaneously across the first face or the substrate in optical contact with the first face;

34. Apparatus according to any of the preceding claims 25 to  
5 33 further comprising
- means for measuring the gap between the hologram and a wafer being arranged in a spaced relationship to the hologram; and
  - means for adjusting the parallelism and/or separation  
10 between the hologram and the wafer.
35. Apparatus according to any of the preceding claims 25 to  
34 further characterized in that the directing means for  
the reference light beam further arranges that the angle  
15 of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .
36. Apparatus according to any of the preceding claims 25 to  
20 35 characterized in that the photoresist employed has a refractive index at the exposure wavelength of greater than 1.6 and preferably greater than 1.7.
37. Total internal reflection holographic recording  
25 apparatus or system for recording a hologram from a mask, comprising
- an optical coupling element for receiving a substrate on a first face;
  - a substrate bearing a holographic recording medium, the  
30 substrate being in optical contact with said first face of the optical coupling element,
  - at least one light source for generating a light beam;

- 29 -

- optical means for generating a collimated light beam of a selected cross-section;
  - means, e.g. a beam-splitter, prism or the like, for generating two coherent light beams, a reference light beam and an object light beam;
  - means for directing the reference light beam at a second face of the coupling element such that it illuminates the interface between the first face and the ambient medium or the interface between a substrate in optical contact with said first face and the ambient medium at an angle greater than the critical angle;
  - means for directing the object light beam at the first face of the coupling element such that it is aligned with the reference beam in the plane of the holographic recording medium on the substrate in contact with the first face;
- characterized in that
- the holographic recording medium is a photoresist;
  - means are provided for arranging the planes of polarisation of the object and reference beams incident on the holographic recording medium such that their polarisation vectors are substantially mutually orthogonal in the holographic recording medium and such that the polarisation vectors of the incident and totally internally reflected reference beams are substantially orthogonal; and
  - in that the directing means for the reference light beam further arranges that the angle of incidence of the reference beam in the holographic recording layer is less than  $45^\circ$ , preferably less than  $42^\circ$  and most preferably less than  $40^\circ$ .

- 30 -

38. Apparatus according to claim 37 and any of claims 26 to 36.

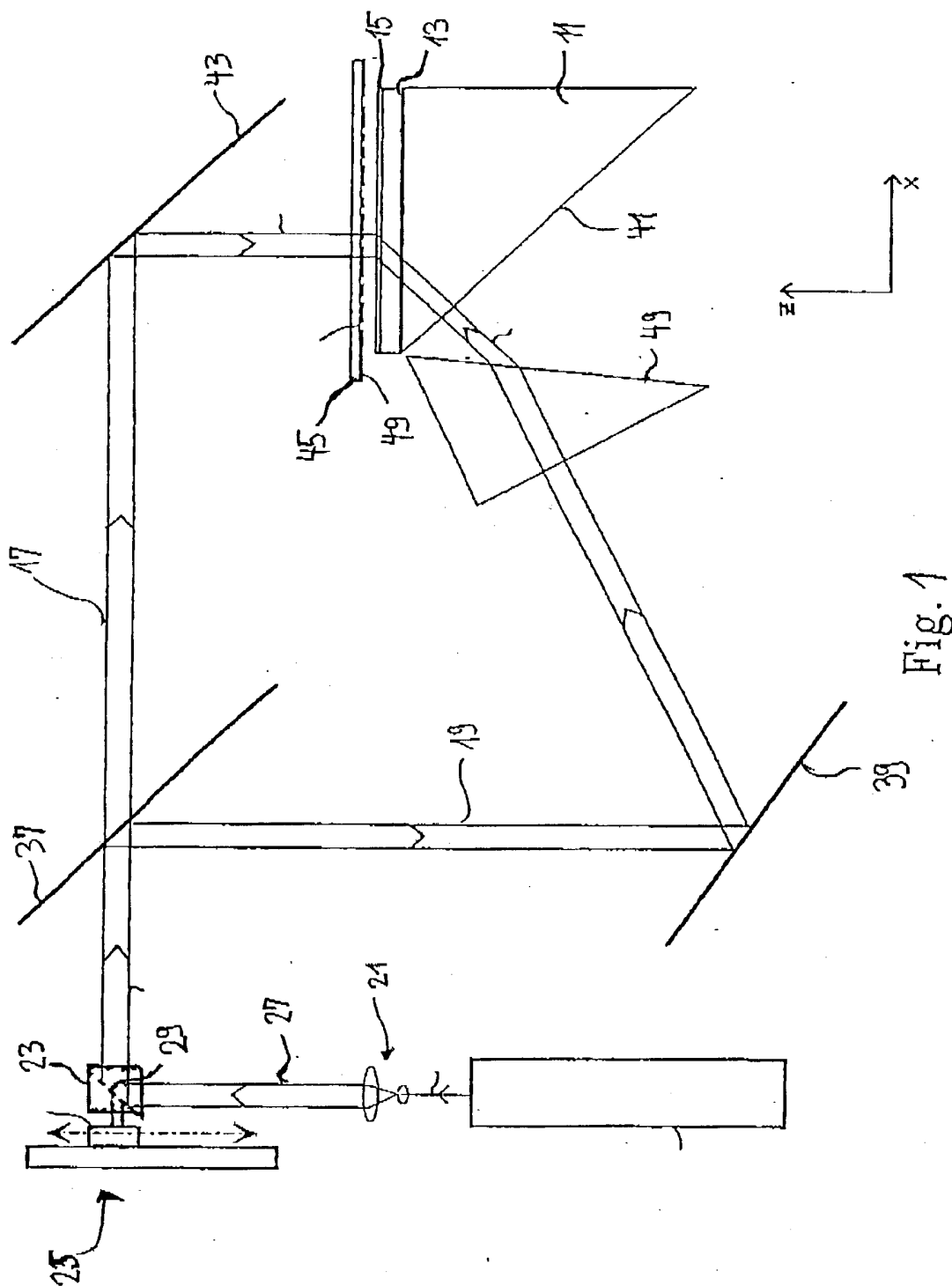
39. Hologram recorded in a recording medium according to  
5 claims 1 to 20 or claims 22 to 24.

- 31 -

Abstract

The present invention relates to a method and an apparatus  
5 for forming a hologram from a mask. According to the  
invention a photoresist is used as the holographic recording  
medium and the planes of polarisation of the object and  
reference beams incident on the holographic recording medium  
are arranged such that their polarisation vectors are  
10 substantially mutually orthogonal in the holographic  
recording medium and such that the polarisation vectors of  
the incident and totally internally reflected reference beams  
are also substantially orthogonal. Preferably, just the  
transmission hologram is formed in the holographic recording  
15 layer.

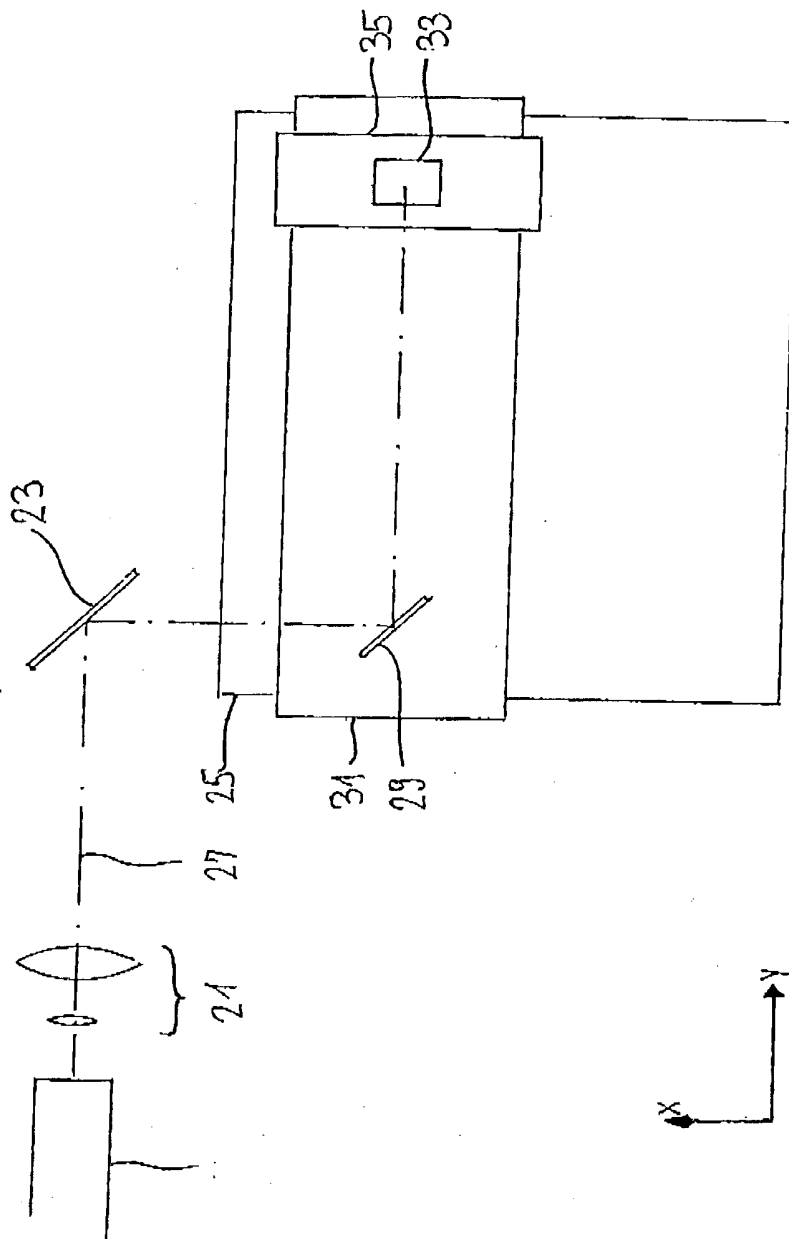
(Fig. 3)



2/3

10/009944

Fig. 2



3/3

10/009944

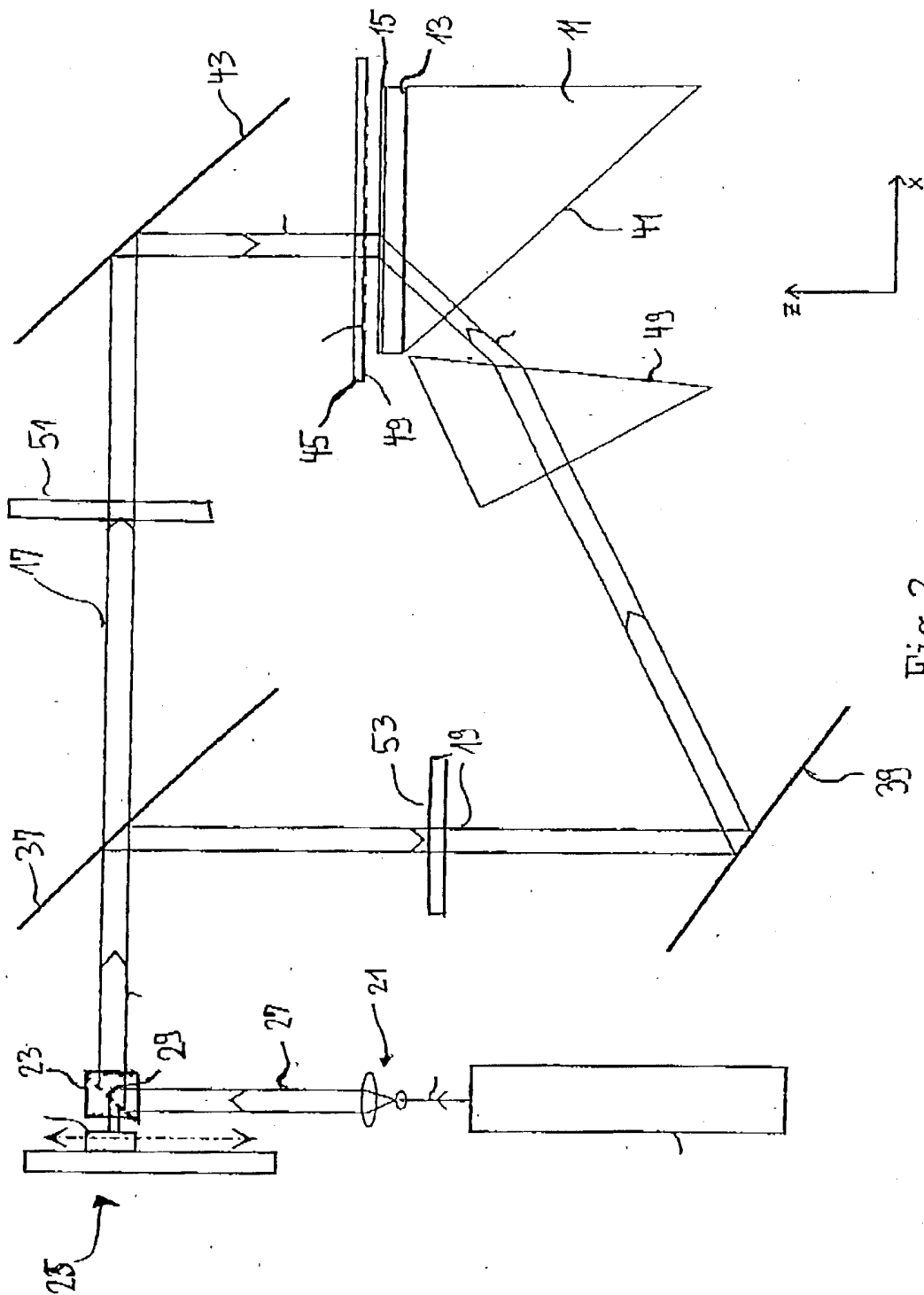


Fig. 3

Docket No. HOLTR-400

**DECLARATION FOR PATENT APPLICATION**

As a below named inventor, I hereby declare that: My residence, post office address and citizenship are as stated below next to my name. I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled

**METHOD AND APPARATUS FOR RECORDING A HOLOGRAM FROM A MASK PATTERN BY THE USE OF TOTAL INTERNAL REFLECTION HOLOGRAPHY AND HOLOGRAM MANUFACTURED BY THE METHOD**

the specification of which was filed on December 11, 2001 as Application Serial No. 10/009,944 and was amended on December 11, 2001.

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims. I acknowledge the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations, §1.56(a).

I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

I hereby claim priority of International application PCT/IB00/00794 filed June 13, 2000 and claim priority of Prior Foreign Application(s)

99111446.3	EPO	11 June, 1999
Number	Country	Date

I hereby appoint Leo Stanger, Reg. No. 19,188 to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith. Address all telephone calls to telephone No. 908-277-8588. Address all correspondence to Leo Stanger, Stanger & Dreyfus, P.C., PO Box 1455, 382 Springfield Avenue, Summit, NJ 07901

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

*O. Carnal*  
 Bern, August 13<sup>th</sup> 2002

Olivier H. Carnal  
 road: Bültening 7, CH-8595 Althaus  
 Switzerland  
 (same address)  
 citizen of Switzerland



Docket No. HOLTR-400

# **DECLARATION FOR PATENT APPLICATION**

As a below named inventor, I hereby declare that: My residence, post office address and citizenship are as stated below next to my name. I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled

## **METHOD AND APPARATUS FOR RECORDING A HOLOGRAM FROM A MASK PATTERN BY THE USE OF TOTAL INTERNAL REFLECTION HOLOGRAPHY AND HOLOGRAM MANUFACTURED BY THE METHOD**

the specification of which was filed on December 11, 2001 as Application Serial No. 10/009,944 and was amended on December 11, 2001.

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims. I acknowledge the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations, S1.56(a). I hereby claim foreign priority benefits under Title 35, United States Code, S119 of any foreign application(s) for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

I hereby claim priority of International application PCT/IB00/00794 filed June 13, 2000, and claim priority of Prior Foreign Application(s)

<u>99111446.3</u>	<u>EPO</u>	<u>11 June, 1999</u>
Number	Country	Date

I hereby appoint Leo Stanger, Reg. No. 19,188 to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith. Address all telephone calls to telephone No. 908-277-8588. Address all correspondence to Leo Stanger, Stanger & Dreyfus, P.C., PO Box 1455, 382 Springfield Avenue, Summit, NJ 07901

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Docket No. HOLTR-400

### DECLARATION FOR PATENT APPLICATION

As a below named inventor, I hereby declare that: My residence, post office address and citizenship are as stated below next to my name. I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled

**METHOD AND APPARATUS FOR RECORDING A HOLOGRAM FROM A MASK PATTERN BY THE USE OF TOTAL INTERNAL REFLECTION HOLOGRAPHY AND HOLOGRAM MANUFACTURED BY THE METHOD**

the specification of which was filed on December 11, 2001 as Application Serial No. 10/009,944 and was amended on December 11, 2001.

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims. I acknowledge the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations, §1.56(a). I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

I hereby claim priority of International application **PCT/IB00/00794** filed **June 13, 2000**, and claim priority of Prior Foreign Application(s)

<u>99111446.3</u>	<u>EPO</u>	<u>11 June, 1999</u>
Number	Country	Date

I hereby appoint Leo Stanger, Reg. No. 19,188 to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith. Address all telephone calls to telephone No. 908-277-8588. Address all correspondence to Leo Stanger, Stanger & Dreyfus, P.C., PO Box 1455, 382 Springfield Avenue, Summit, NJ 07901

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Method and apparatus for recording a hologram from a mask pattern by the use of total internal reflection holography and hologram manufactured by the method

US Patent Application Serial No 10/009,944 filed on 11.12.2001

Full name of sole or inventor Woo-Sung Han

*W*  
Inventor's Signature W. S. Han

Aug. 12, 2002  
Date

Korean  
Citizenship

Residence: Yeoksam Hanshin Apt. 2-1305, Dogk-Dong 895-8, Seocho-Gu, Seoul, South Korea

Post Office Address: Yeoksam Hanshin Apt. 2-1305, Dogk-Dong 895-8, Seocho-Gu, Seoul, South Korea *KRW*

Full name of the joint inventor: Olivier Carnal

*W*  
Inventor's Signature

Date

Citizenship

Residence: Büttenring 7, CH-8595 Altnau, Switzerland

Post Office Address: Büttenring 7, CH-8595 Altnau, Switzerland *CH/X*

Full name of sole or first inventor **Woo-Sung Han**

\_\_\_\_\_  
Inventor's Signature

\_\_\_\_\_  
Date

\_\_\_\_\_  
Citizenship

Residence: **Yeoksam Hanshin Apt. 2-1305, Dogk-Dong 895-8, Seocho-Gu, Seoul, South Korea**

Post Office Address: **Yeoksam Hanshin Apt. 2-1305, Dogk-Dong 895-8, Seocho-Gu, Seoul, South Korea**

Full name of second joint inventor: **Francis Stace Murray Clube**

*FR*  
*FR* *MC*  
\_\_\_\_\_  
Inventor's Signature

*May 22, 2002*  
\_\_\_\_\_  
Date

*BRITISH*  
\_\_\_\_\_  
Citizenship

Residence: **Chemin des Ribaudes 26, CH-2000 Neuchâtel, Switzerland**

Post Office Address: **Chemin des Ribaudes 26, CH-2000 Neuchâtel, Switzerland**

Full name of the third joint inventor: **Olivier Carnal**

\_\_\_\_\_  
Inventor's Signature

\_\_\_\_\_  
Date

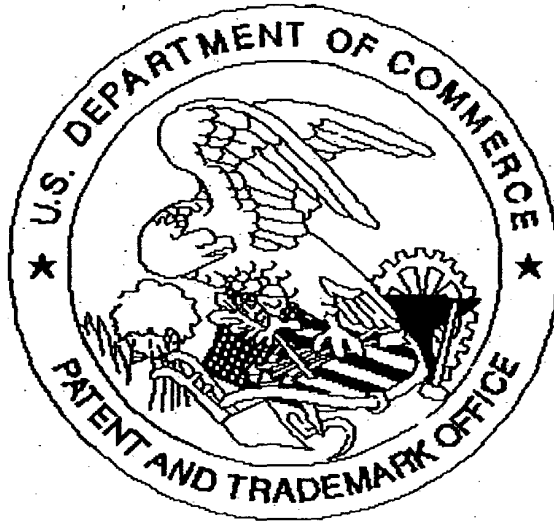
\_\_\_\_\_  
Citizenship

Residence: **Bütenring 7, CH-8595 Altnau, Switzerland**

Post Office Address: **Bütenring 7, CH-8595 Altnau, Switzerland**

*CTX*

United States Patent & Trademark Office  
Office of Initial Patent Examination -- Scanning Division



Application deficiencies found during scanning:

☐ Page(s) \_\_\_\_\_ of \_\_\_\_\_ were not present  
for scanning. (Document title)

☐ Page(s) \_\_\_\_\_ of \_\_\_\_\_ were not present  
for scanning. (Document title)

*Scanned copy is best available declaration page 4 have line*